Attorney Docket No. 0756-2330



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Group Art Unit: 2823
Shunpei YAMAZAKI et al.)	Examiner: B. Kebede
Serial No. 09/894,125)	CERTIFICATE OF MAILING I hereby certify that this correspondence is being
Filed: June 29, 2001)	deposited with the United States Postal Service with sufficient postage as First Class Mail in a
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FABRICATING THE SAME,)	addith Stamper
SEMICONDUCTOR DEVICE, AND)	
METHOD OF FABRICATING THE)	
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INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner of Patents

P.O. Box 1450

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Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing references known to Applicant and requests that these references be made of record in the above identified application. Copies of the references listed are submitted herewith in accordance with 37 C.F.R. 1.98(a).

This Information Disclosure Statement is being submitted with an RCE. Therefore, no fee is required.

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be

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Respectfully submitted,

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STATEMENT BY APPLICANT (use as many sheets as necessary)		Filing Date	June 29, 2001			
		First Named Inventor	Shunpei YAMAZAKI et al.			
		Group Art Unit	2823			
		Examiner Name	B. Kebede			
Sheet	1	of	1	Attorney Docket Number	0756-2330	

U.S. PATENT DOCUMENTS							
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited	Date of Publication of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		Number	Kind Code ² (if known)	Document	MM-DD-YYYY		
		5,869,387		Sato et al.	02/09/1999		
		5,985,681		Hamajima et al.	11/16/1999		
		6,221,738		Sakaguchi et al.	04/24/2001		
		6,335,541		Ohtani et al.	01/01/2002		
		6,559,036		Ohtani et al.	05/06/2003		
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Examiner Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or	Date of Publication of Cited	Pages, Columns, Lines, Where Relevant Passages or Relevant	
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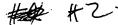
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¹ Unique citation designation number. ² Applicant is to place a check mark here if English language Translation is attached.



Substitute for form 1449 A/PTO nplete if Known RMATION DISCLOSURE STATEMENT Application Number Filing Date June 29, 2001 BY APPLICANT First Named Inventor Shunpei YAMAZAKI et al. e as many sheets as necessary) Group Art Unit 2823 **Examiner Name** B. Kebede Attorney Docket Number 740756-2330 U.S. PATENT DOCUMENTS Date of Publication of Cited U.S. Patent Document Pages, Columns, Lines, Where Relevant Cite No.1 Name of Patentee or Applicant of Cited Document MM-DD-YYYY Passages or Relevant Figures Appear Documen Kind Code Number 5,147,826 09/15/1992 Liu et al. 5,461,250 Burghartz et al. 10/24/1995 4,986,213 Yamazaki et al. 01/22/1991 6,124,154 Miyasaka 09/26/2000 5,403,772 04/04/1995 Zhang et al. 5,426,064 06/20/1995 Zhang et al. 5,639,698 Yamazaki et al. 06/17/1997 5,843,833 Ohtani et al. 12/01/1998 5,994,172 Ohtani et al. 11/30/1999 5,879,977 Zhang et al. 03/09/1999 6,140,165 Zhang et al. 10/31/2000 6,096,581 Zhang et al. 08/01/2000 6,054,739 Yamazaki et al. 04/25/2000 6,027,960 Kusumoto et al. 02/22/2000 FOREIGN PATENT DOCUMENTS Cite No. Date of Publication of Cited Foreign Patent Documen Pages, Columns, Lines, Name of Patentee or Document MM-DD-YYYY Where Relevant Passages or Relevant Figures Appear Initials Kind Code Applicant of Cited Document Office3 Number (if known) OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS Examiner Cite Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the T2 Initials item (book, magazine, journal, serial, symposium, catalog, etc.)., date, page(s), volume-issue number(s), publisher, city and/or country where published. Dorin et al., "Chemistry The Study of Matter", 1992, pp. 532, Prentice Hall Aya et al., "Improvement of SPC poly-Si Film Using the ELA Method", September 11-12, 1997, pp. 167-170, AM-LCD. Abe et al., High-Performance Poly-Crystalline Silicon TFT's Fabricated Using the SPC and ELA Methods", July 9-10, 1998, pp. 85-88, AM-LCD. "Thresholds antiferroelectricity in liquid crystals and its application to displays", S. Inui et al., J. Mater. Chem., 6 (4), pages 6/1-673, 1996. U.S. Patent Application Serial No. 09/369,158 "Semiconductor Device and Method of Manufacturing the BK Same". U.S. Patent Application Serial No. 09/352,194 "Crystalline Semiconductor Thin Film, Method of Fabricating the Same Semiconductor Device, and Method of Fabricating the Same". BN Examiner Brook Kehede 40m/20,2002 Signature Considered